Reply to Office Action of January 25, 2010

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in

the application:

<u>Listing of Claims</u>:

1. (Currently amended): A multi-layer piezoelectric element comprising:

a stack having an active portion constituted from at least one piezoelectric

layer and a plurality of internal electrodes consisting of the first and the second

internal electrodes placed one on another, the active portion being subjected to

expansion and contraction in response to a voltage applied across the first internal

electrode and the second internal electrode; and

external electrodes formed on two side faces of the stack, one of said external

electrodes being connected to the first internal electrode and the other of said

external electrodes being connected to the second internal electrode,

wherein each of the external electrodes has three or more layers including a

first layer containing a metal oxide and formed in contact with the side face of the

stack, and a second layer containing a metal oxide and formed on the first layer,

and an outermost layer containing a metal oxide,

wherein a content of the metal oxide in the first layer is more than a content

of the metal oxide in the second layer, and the content of the metal oxide in the

second layer is more than a content of the metal oxide in the outermost layer.

2. (Original): The multi-layer piezoelectric element according to claim

1, wherein a thickness of the first layer is 10  $\mu m$  or less.

3-4. (Canceled):

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5. (Currently amended): The multi-layer piezoelectric element according to claim 3, wherein the metal oxide is a glass and the glass component is dispersed in

the grain boundaries of a metal component that constitutes the external electrode.

6. (Previously presented): The multi-layer piezoelectric element

according to claim 1, wherein the stack has inactive layers made of a piezoelectric

material located on both ends, the inactive layers including dispersed metal.

7. (Withdrawn): A multi-layer piezoelectric element comprising:

a stack having an active portion constituted from at least one piezoelectric

layer and a plurality of internal electrodes consisting of the first and the second

internal electrodes placed one on another, and inactive layers made of a

piezoelectric material located on both ends of the active portion, the active portion

being subjected to expansion and contraction in response to a voltage applied across

the first internal electrode and the second internal electrode; and

external electrodes formed on two side faces of the stack, one of said external

electrodes being connected to the first internal electrode and the other of said

external electrodes being connected to the second internal electrode,

wherein the inactive layers of the stack include dispersed metal.

8. (Withdrawn): The multi-layer piezoelectric element according to claim

7, wherein said metal is at least one selected from a group consisting of Ag. Pd. Cu.

Ca, Na, Pb and Ni.

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9. (Withdrawn): The multi-layer piezoelectric element according to claim 7, wherein an amount of said dispersed metal is in a range from 0.001 to 1.0% by weight in proportion to the inactive layer 12.

- 10. (Withdrawn) The multi-layer piezoelectric element according to claim 7, wherein a thickness of the inactive layer is in a range from 0.1 mm to 2.0 mm.
- 11. (Withdrawn): The multi-layer piezoelectric element according to claim 7, wherein said metal has the same composition as the internal electrode.
- 12. (Withdrawn): The multi-layer piezoelectric element according to claim 1, wherein a metal compound in the internal electrode includes group 8 to group 10 metal and/or group 11 metal as the main components.
- 13. (Withdrawn): The multi-layer piezoelectric element according to claim 12, wherein a proportion M1 (% by weight) of the group 8 to group 10 metal and a proportion M2 of the group 11 metal satisfy the relations  $0 < M1 \le 15$ ,  $85 \le M2 < 100$  and M1 + M2 = 100.
- 14. (Withdrawn): The multi-layer piezoelectric element according to claim 12, wherein said the group 8 to group 10 metal is at least one selected from a group consisting of Ni, Pt, Pd, Rh, Ir, Ru and Os, and the group 11 metal is at least one selected from a group consisting of Cu, Ag and Au.

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15. (Withdrawn): The multi-layer piezoelectric element according to claim

12, wherein said the group 8 to group 10 metal is at least one selected from a group

consisting of Pt and Pd, and the group 11 metal is at least one selected from a group

consisting of Ag and Au.

16. (Withdrawn): The multi-layer piezoelectric element according to claim

12, wherein said the group 8 to group 10 metal is Ni.

17. (Withdrawn): The multi-layer piezoelectric element according to claim

12, wherein said group 11 metal is Cu.

18. (Withdrawn): The multi-layer piezoelectric element according to claim

12, wherein one selected from a group consisting of oxide, nitride or carbide is added

along with the metal compound in the internal electrode.

19. (Withdrawn): The multi-layer piezoelectric element according to claim

18, wherein said oxide includes the perovskite type oxide of PbZrO<sub>3</sub>- PbTiO<sub>3</sub> as the

main component.

20. (Withdrawn): The multi-layer piezoelectric element according to claim 1,

wherein the piezoelectric layer includes perovskite type oxide as the main

component.

21. (Withdrawn): The multi-layer piezoelectric element according to claim

20, wherein said piezoelectric layer includes the perovskite type oxide of PbZrO<sub>3</sub>-

PbTiO<sub>3</sub> as the main component.

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22. (Withdrawn): The multi-layer piezoelectric element according to claim 1;

wherein grooves are formed between the second internal electrodes and the

external electrodes on said one side face,

wherein grooves are formed between the first internal electrodes and the

external electrodes on other side face,

wherein each of the grooves being filled with an insulating material that has

Young's modulus lower than that of the piezoelectric material.

23. (Withdrawn): A method of manufacturing a multi-layer piezoelectric

element comprising:

a step of forming piezoelectric layers on both end faces of a green stack made

by stacking green sheets of piezoelectric material and electrically conductive layers

alternately;

a step of forming a metal layer on the piezoelectric layer; and

a step of firing the green stack having the piezoelectric layer and the metal

layer formed thereon and then removing the metal layer.

24. (Withdrawn): The method of manufacturing a multi-layer piezoelectric

element according to claim 23; wherein the metal layer has a melting point not

higher than 1.6 times the firing temperature of the multi-layer piezoelectric

element.

25. (Withdrawn): The method of manufacturing a multi-layer piezoelectric

element according to claim 23; wherein the thickness of the metal layer is 5 mm or

less.

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